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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/787,405	02/27/2004	Heon-Do Yun	041993-5364	4520	
30827 75	90 08/07/2006		EXAM	INER	
MCKENNA LONG & ALDRIDGE LLP			CHIEN, LUCY P		
1900 K STREE' WASHINGTON			ART UNIT	PAPER NUMBER	
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			DATE MAILED: 08/07/200	DATE MAILED: 08/07/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

			on				
	Application No.	Applicant(s)					
Office Action Commence	10/787,405	YUN ET AL.					
Office Action Summary	Examiner	Art Unit					
	Lucy P. Chien	2871					
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet wit	h the correspondence addre	ess				
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA  - Extensions of time may be available under the provisions of 37 CFR 1.1: after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period v  - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNIC 36(a). In no event, however, may a re will apply and will expire SIX (6) MON c, cause the application to become ABA	CATION.  sply be timely filed  ITHS from the mailing date of this comm  ANDONED (35 U.S.C. § 133).					
Status							
1) Responsive to communication(s) filed on	<u>_</u> .						
2a) ☐ This action is FINAL. 2b) ☑ This	action is non-final.						
	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims							
4) ☑ Claim(s) 2,3 and 8-21 is/are pending in the approach 4a) Of the above claim(s) 8-16 is/are withdrawn 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 2 and 17-21 is/are rejected. 7) ☐ Claim(s) 3 is/are objected to. 8) ☐ Claim(s) are subject to restriction and/o	n from consideration.						
Application Papers							
9) ☐ The specification is objected to by the Examine 10) ☑ The drawing(s) filed on 27 February 2004 is/are Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) ☐ The oath or declaration is objected to by the Ex	e: a)⊠ accepted or b)☐ c drawing(s) be held in abeyan tion is required if the drawing(	ce. See 37 CFR 1.85(a). s) is objected to. See 37 CFR	1.121(d).				
Priority under 35 U.S.C. § 119	·						
12) ☒ Acknowledgment is made of a claim for foreign  a) ☒ All b) ☐ Some * c) ☐ None of:  1 ☒ Certified copies of the priority documents  2 ☐ Certified copies of the priority documents  3 ☐ Copies of the certified copies of the priority application from the International Bureau  * See the attached detailed Office action for a list	s have been received. s have been received in Aprity documents have been u (PCT Rule 17.2(a)).	oplication No received in this National Sta	age				
·							
Attachment(s)  1) Notice of References Cited (PTO-892)	4) Interview S	ummary (PTO-413)					
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	Paper No(s	nifficial (PTO-413) /Mail Date formal Patent Application (PTO-15	52)				

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#### **ODETAILED ACTION**

# Response to Arguments

Applicant's arguments with respect to claim 2 have been considered but are moot in view of the new ground(s) of rejection.

# Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 2,17-21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akahira (US 6471352) and of Ueno (JP 09-166783) in view of Marumoto et al (US 6277529).

Akahira discloses (figure 27C) providing a substrate having a plurality of unit panels formed thereon, loading the substrate onto a stage (Fig. 1, 52) and forming an alignment layer on the substrate to have a uniform thickness selectively dropping ink onto a first one of the unit panel regions by a dropping unit (Figure 1, items 55 and Figure 3, nozzles 108), having a plurality at least one head each head having a plurality of holes (Figure 27D). Wherein the selective dropping of the alignment material onto the substrate.

Akahira does not disclose dropping alignment material. Nor does Akahira disclose the specific movement of the alignment material dropping unit.

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Ueno discloses using the dropping unit panels for dropping alignment material.

(Abstract)

Marumoto et al discloses positioning the alignment material dropping unit at a first side of the stage (fig. 1, Column 1, rows 55-67) driving the alignment material dropping unit from the first side to a second side (The 4 direction) of the stage to drop the alignment material through holes along a plurality of first dropping directions shifting (the 5 direction) the alignment material dropping unit by a predetermined distance along a direction perpendicular to the first dropping direction driving the alignment material dropping unit from the second side to the first side of the stage to drop the alignment material through holes along a plurality of second dropping directions.

It would have been obvious to one of ordinary skilled in the art to modify

Akahira's method of forming color film using a plurality of unit panels to include Ueno's method of forming an alignment film that uses a plurality of unit panels to prevent a decrease in the display performance by providing a uniform orienting film (Abstract).

Also, to include Marumoto et al's dropping unit movement motivated by the desire to provide the display with a method of dropping ink on the substrate evenly and effectively.

### Allowable Subject Matter

Claim 3 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

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The following is a statement of reasons for the indication of allowable subject matter: The shift distance of the alignment material dropping unit is smaller than a distance between the holes.

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lucy P. Chien whose telephone number is 571-272-8579. The examiner can normally be reached on M-F 8:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571)272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Lucy P Chien Examiner Art Unit 2871

> And Schechter NDREW SCHECHTER PRIMARY EXAMINER